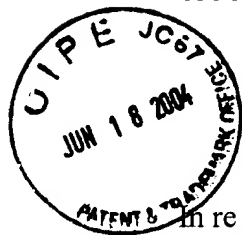


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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

HIROSHI IZAWA ET AL.

Application No.: 09/837,459

Filed: April 19, 2001

For: DEPOSITED-FILM
FORMATION APPARATUS,
DEPOSITED-FILM
FORMATION PROCESS,
VACUUM SYSTEM, LEAK
JUDGMENT METHOD, AND
COMPUTER-READABLE
RECORDING MEDIUM WITH
RECORDED LEAK-JUDGMENT-
EXECUTABLE PROGRAM

Examiner: Rudy Zervigon

Group Art Unit: 1763

June 14, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) Introductory Comments

In response to the Office Actions dated March 12, 2004 and June 4, 2004,

kindly amend the subject application as follows.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

June 14, 2004 (Reg. No. 24947)
(Date of Deposit)

PETER SAXON

(Name of Attorney for Applicant)

Peter Saxon

Signature

June 14, 2004

Date of Signature